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P.001/004 F-809

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TRANSMITTAL FORM (to be used for all correspondence after initial filing)				Application Number	09/824,931
				Filing Date	4/3/2001
				First Named Inventor	Michael P. Mittmann
				Art Unit	1631
				Examiner Name	Ardin H. Marschel
Total Number of Pages in This Submission			4	Attorney Docket Number	3381
ENCLOSURES (check all that apply)					
Fee Transmittal Form			☐ Drawing(s)		After Allowance Communication to Technology Center (TC)
Fee Attached			Licensing-related Papers		Appeal Communication to Board of Appeals and Interferences
Amendment / Reply			Petition		Appeal Communication to TC (Appeal Notice, Brief, Reply Brief)
After Final			Petition to Convert to a Provisional Application		Proprietary Information
Affidavits/declaration(s)			Power of Attorney, Revocation Change of Correspondence Address		Status Letter
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☐ Information Disclosure Statement			CD, Number of CD(s)		
Certified Copy of Priority			Remarks		
Document(\$) Response to Missing Parts/ Incomplete Application			Summary of Personal Interview conducted July 20, 2004		
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Parts under 37 CFR 1.52 or 1.53					
SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT					
Firm or Unilliam R. McCarthy III Reg. No. 55,70 Individual name					, .
Signature Willim A			N. That II		
Date 8/5/2004					
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RECEIVED 7816879090

Application No.: 09/824,931

P.002/004

Attorney Docket No. 3381

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Mittmann et al.

Examiner: Ardin H. Marschel

Serial No: 09/824,931

Group Art Unit: 1631

Filing Date: 4/3/01

Title: Photolithographic Method and System for Efficient Mask Usage in

Manufacturing DNA Arrays

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

INTERVIEW SUMMARY UNDER 37 C.F.R. 1.133

Dear Examiner Marschel:

This Interview Summary is hereby submitted in connection with the personal interview held on July 20, 2004, in regard to the above-referenced application. In attendance were Applicant's representatives William R. McCarthy III, and Philip L. McGarrigle, and Examiner Ardin H. Marschel.

Applicants wish to thank the Examiner for conducting the above interview to discuss the present invention. During the interview, Applicant's representative, Mr. McCarthy, described the invention with respect to a Response filed July 1, 2004 to the Office Action mailed January 5, 2004.

Specifically, Mr. McCarthy argued that that the reference (Hess et al. US 2002/0094533) applied with respect to the rejection to Claims 1-16 under 35 USC 102 (e) (1) does not teach the limitations required by the claims, in particular the subdivision of a mask into reticle areas, where each reticle area is further subdivided into reticles. Mr.

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McCarthy also argued that each reticle area is associated with a synthesis area on a substrate, and that the invention of subdividing areas on the mask reduces the total number of masks required for synthesizing polymers.

Examiner Marschel responded that the limitations as currently claimed do not represent the described invention. Examiner Marschel suggested possible limitations that could help define the claimed invention.

Examiner Marschel also pointed to a reference (Pierrat U.S. Patent Serial No. 6,040,892) from a recently submitted Information Disclosure Statement (IDS filed January 8, 2004), suggesting consideration of the reference if Applicants choose to amend Claims.

It is believed that no fee is required for the submission of this response. However, if a fee is required, the Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account 01-0431.

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T-779 P.004/004 F-809

Application No.: 09/824,931

Respectfully submitted,

By William I The the MI

William R. McCarthy III Reg. No.: 55,788

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